

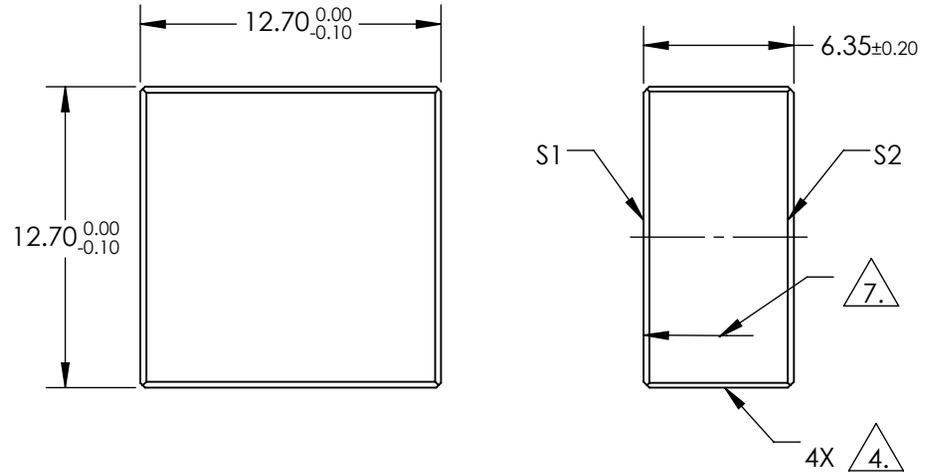
NOTES:

1. SUBSTRATE:
Fused Silica
2. SURFACE S1 TO BE PARALLEL TO SURFACE S2 TO WITHIN <3 ARCMINS
3. COATING (APPLY ACROSS COATING APERTURE)

S1: R(ABS) >99.8% @ 515nm
 DAMAGE THRESHOLD,
 PULSED: 10 J/cm² @ 515nm, 20ns, 20Hz
 CW: 1MW/cm² @ 515nm

S2: NONE

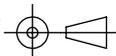
4. FINE GROUND SURFACE
5. CLEAR APERTURE AND COATING APERTURE ARE CENTERED ON SURFACE
6. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
7. ARROW ON EDGE WITH LASER ETCH, PENCIL, OR PERMANENT INK POINTS TOWARDS SURFACE S1



**FOR INFORMATION ONLY:
 DO NOT MANUFACTURE
 PARTS TO THIS DRAWING**

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
 DIMENSIONS ARE FOR REFERENCE ONLY

	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	10-5	COMMERCIAL POLISH
SURFACE FLATNESS	0.10 WAVE	N/A
MIN CLEAR APERTURE	10.80 x 10.80	N/A
MIN COATING APERTURE	10.80 x 10.80	N/A
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

THIRD ANGLE PROJECTION 

ALL DIMS IN mm

 **Edmund Optics®**

TITLE: 12.7 x 12.7mm 515nm 0-45°, Yb:YAG Laser Line Mirror

DWG NO: 39634

SHEET 1 OF 1